

COPY

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**REQUEST FOR APPROVAL OF PROPOSED DRAWING CORRECTIONS**

jc917 U.S. PTO  
09/678459  
10/03/00

APPLICANT: Ino et al  
SERIAL NO.: 08/878,588 GROUP ART UNIT: 2813  
DATE FILED: June 19, 1997 EXAMINER: S. Hawranek  
INVENTION: "PROCESS FOR FABRICATING THIN  
FILM SEMICONDUCTOR DEVICE"


Assistant Commissioner for Patents  
Washington, D.C. 20231

S I R:

Applicants are proposing to add legends to Figs. 13-16, as indicated in red in the attached two sheets of drawings, to meet with the request of the Examiner.

Formal Drawings containing these changes will be submitted once the application has been allowed.

Respectfully submitted,

  
(Reg. No. 24,149)  
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A Professional Corporation  
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Chicago, Illinois 60606

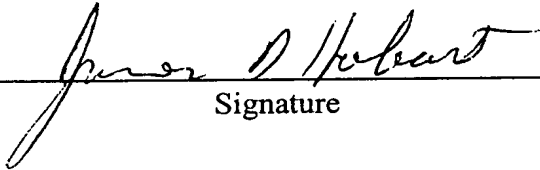
Telephone: (312) 876-0200 - Ext. 647

DATED: May 12, 1999

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on May 12, 1999.

James D. Hobart  
Name of Applicant's Attorney

  
Signature

May 12, 1999  
Date

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